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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
YASUO SUDA		;	
Application No.: Not Yet Assigned)	
Filed:	Concurrently Herewith)	
For:	SEMICONDUCTOR DEVICE AND ITS MANUFACTURE METHOD	; ; ;	July 30, 2003

This application is a divisional under 37 C.F.R. § 1.53(b) of U.S. Patent Appln. No. 10/099,960

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

CLAIM TO PRIORITY

Sir:

Applicant hereby claims priority under the International Convention and all rights to which he is entitled under 35 U.S.C. § 119 based upon the following Japanese priority applications:

Japan 2001-081000, filed March 21, 2001; and Japan 2001-108726, filed April 6, 2001.

Certified copies of the priority documents were submitted in parent Application No. 10/099,960.

Applicant's undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicant

Registration No. 52,3/0

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3801

Facsimile: (212) 218-2200

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